

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application of: |) | |
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| Katsumi SHIBAYAMA |) | Confirmation No.: 4347 |
| |) | |
| Application No.: 10/550,689 |) | Group Art Unit: 2814 |
| |) | |
| Filed: July 21, 2006 |) | |
| |) | Examiner: Anh D. Mai |
| For: PHOTODIODE ARRAY AND |) | |
| RADIATION DETECTOR HAVING |) | |
| DEPRESSIONS OF |) | |
| PREDETERMINED DEPTH FORMED |) | |
| IN REGIONS CORRESPONDING TO |) | |
| THE REGIONS WHERE THE |) | |
| PHOTODIODES ARE FORMED IN |) | |
| THE SEMICONDUCTOR |) | |
| SUBSTRATE (As Amended) |) | |

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the non-final Office Action dated June 3, 2009, the period for response to which extends through October 5, 2009 (October 3, 2009 being a Saturday), by the concurrently-filed petition for a one-month extension of time and corresponding fee payment, please amend the above-identified application as follows: